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Attorney's Docket No.: 42P17764

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Patent Application of:

**Alejandro Hurtado**

Application No.: 10/769,534

Filed: **January 30, 2004**

For: **MOUNTING AND DICING PROCESS  
FOR WAFERS**

Examiner: **Ha, Nathan W.**

Art Unit: **2814**

Confirmation No.: **8641**

**MAIL STOP RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450**

**PRELIMINARY AMENDMENT**

Sir:

In connection with the filing a Request for Continued Examination under 37 CFR §1.114, Applicants respectfully request consideration of the following amendment.